## What is Claimed is:

A method for preventing contamination after plating a metal or an alloy on a [c1] surface of a substrate comprising: a) providing a plating solution on the surface of the substrate; b) electroplating or electrolysis plating the metal or alloy on the surface of the substrate; and, c) introducing a stabilizing agent which keeps metal or alloy ions in the plating solution. Method according to claim 1, wherein in said introducing step (c) the stabilizing [c2] agent prevents formation of precipitated salts on the surface of the substrate. Method according to claim 1, wherein the stabilizing agent comprises an [c3] aqueous solution of a complexing agent for the plating metals. The first give many way, way, rang, Method according to claim 3, wherein the complexing agent comprises an [c4] organic or inorganic compound. Method according to claim 3, wherein the complexing agent comprises a [c5] Hart the Bean the Hall Hall mixture of an organic compound and an inorganic compound. Method according to claim 3, wherein the aqueous solution of the complexing [c6] agent for the plating metals comprises Citrate, Acetate, EDTA, or Ammonia. Method according to claim 6, wherein in said introducing step (c) at least one of [c7] the aqueous solutions of the complexing agent is introduced in the following concentrations: Citrate in a preferred concentration of about 0.5 to about 1.0 mol/kg, Acetate in a preferred concentration of about 0.5 mol/kg, EDTA in a preferred concentration of about 0.2 to about 0.5 mol/kg, and/or Ammonia in a preferred concentration of about 0.1 to about 1.0 mol/kg. Method according to claim 1, wherein the stabilizing agent comprises an acid. [c8] [c9] Method according to claim 8, wherein the acid does not form a low-soluble salt

[c19]

with the plated metals. Method according to claim 8, wherein the acid comprises an organic or [c10]inorganic compound. Method according to claim 8, wherein the acid comprises a mixture of an [c11] organic compound and an inorganic compound. Method according to claim 8, wherein the acid comprises aqueous solutions of [c12]Hydrochloric Acid, Sulfuric Acid, or Phosphoric Acid. Method according to claim 12, wherein in said introducing step (c) at least one [c13] of the aqueous solutions is introduced in the following concentrations: Hydrochloric Acid in a preferred concentration of about 0.1 mol/kg, Hydrochloric Acid in a preferred concentration of about 0.01 mol/kg, Sulfuric Acid in a preferred concentration of about 0.05 mol/kg, and/or Phosphoric Acid in a preferred concentration of about 0.1 mol/kg. Method according to claim 1, wherein the stabilizing agent comprises a mixture [c14] of an aqueous solution of a complexing agent for the plating metals and an acid. Method according to claim 1, wherein the stabilizing agent is contained in the [c15] plating solution. Method according to claim 1, wherein the substrate comprises a semiconductor [c16] wafer. A solution for preventing contamination after plating a metal or an alloy on a [c17] surface of a substrate comprising: a plating solution; and a stabilizing agent which keeps metal or alloy ions in the plating solution. The solution according to claim 17, wherein the stabilizing agent prevents [c18] formation of precipitated salts on the surface of the substrate.

The solution according to claim 17, wherein the stabilizing agent comprises an

aqueous solution of a complexing agent for the plating metals.

The solution according to claim 19, wherein the complexing agent comprises an [c20] organic or inorganic compound. The solution according to claim 19, wherein the complexing agent comprises a [c21] mixture of an organic compound and an inorganic compound. The solution according to claim 19, wherein the aqueous solution of the [c22] complexing agent for the plating metals comprises Citrate, Acetate, EDTA, or Ammonia. The solution according to claim 22, wherein at least one of the aqueous [c23] solutions of the complexing agent comprises: Citrate in a preferred concentration of about 0.5 to about 1.0 mol/kg, Acetate in a preferred concentration of about 0.5 mol/kg, EDTA in a preferred concentration of about 0.2 to about 0.5 mol/kg, and/or Ammonia in a preferred concentration of about 0.1 to about 1.0 mol/kg. The solution according to claim 17, wherein the stabilizing agent comprises an [c24] acid. The solution according to claim 24, wherein the acid does not form a low-[c25] soluble salt with the plated metals. The solution according to claim 24, wherein the acid comprises an organic or [c26] inorganic compound. The solution according to claim 24, wherein the acid comprises a mixture of an [c27] organic compound and an inorganic compound. The solution according to claim 24, wherein the acid comprises aqueous [c28] solutions of Hydrochloric Acid, Sulfuric Acid, or Phosphoric Acid. [c29] The solution according to claim 28, wherein at least one of the aqueous solutions of the acid comprises: Hydrochloric Acid in a preferred concentration of about 0.1 mol/kg, Hydrochloric Acid in a preferred concentration of about 0.01 mol/kg,

Sulfuric Acid in a preferred concentration of about 0.05 mol/kg, and/or Phosphoric Acid in a preferred concentration of about 0.1 mol/kg.

- [c30] The solution according to claim 17, wherein the stabilizing agent comprises a mixture of an aqueous solution of a complexing agent for the plating metals and an acid.
- [c31] The solution according to claim 17, wherein the stabilizing agent is contained in the plating solution.
- [c32] The solution according to claim 17, wherein the substrate comprises a semiconductor wafer.
- [c33] In a method for plating a metal alloy on a surface of a substrate by electrolytic activity using a plating solution on the surface wherein the improvement comprises introducing a stabilizing agent onto the substrate surface in order to keep metal alloy ions in the plating solution.